

## IN THE UNITED STATES PATENT OFFICE

IN THE UNITED STATE	ES PAT	ENT OFFICE	#12/Pre.
In re patent application of:	)	Defenda Francisco	/ C
Rao V. Annapragada	)	Before the Examiner Asok K. Sarkar	marsha
Application No. 09/902,056	)	G A . II .: 2000	1 4/4/0
Filed: July 9, 2001	)	Group Art Unit 2829	
A METHOD OF IMPROVING ADHESION OF	)		TECHNOL AT
CAP OXIDE TO NANOPOROUS SILICA FOR INTEGRATED CIRCUIT FABRICATION	)		RECE APR-

## AMENDMENT AND RESPONSE TO OFFICE ACTION

**Assistant Commissioner for Patents** Washington, D.C. 20231

Sir:

In response to the Office Action dated 24 December 2002, please consider the following. Please charge any further extensions of time, other fees due or credit any overpayment to Deposit Account No. 23-3030, but not to include issue fees.

> I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231 on:

CENTER 2800

Date of Deposit: 24 March, 2003

Name of Registered Representative: L. Scott Paynter

Signature:

Date of Signature: 24 March, 2003

Response to Office Action Application No. 09/902,056 Inventor(s): Rao Annapragada Filed: July 9, 2001 Page 1 of 5